



**ELECTRONIC COPY**

LG758521035  
Report verification at igi.org



December 18, 2025  
IGI Report Number **LG758521035**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **OVAL BRILLIANT**  
Measurements **9.87 X 7.26 X 4.61 MM**  
**GRADING RESULTS**  
Carat Weight **2.06 CARATS**  
Color Grade **D**  
Clarity Grade **VS 1**

December 18, 2025  
IGI Report Number **LG758521035**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **OVAL BRILLIANT**  
Measurements **9.87 X 7.26 X 4.61 MM**

**GRADING RESULTS**

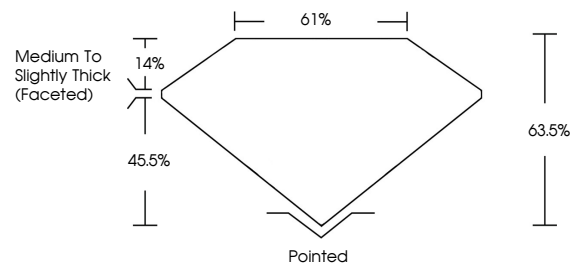
Carat Weight **2.06 CARATS**  
Color Grade **D**  
Clarity Grade **VS 1**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG758521035**

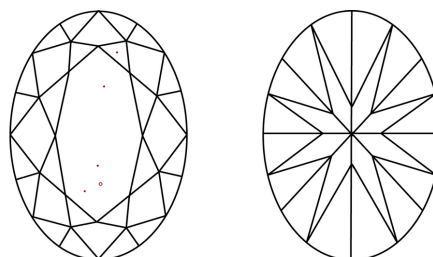
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

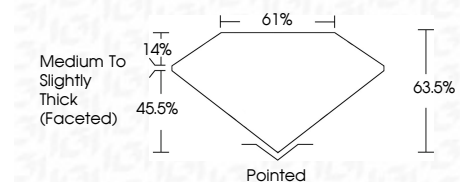
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG758521035**  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa



**IGI**



December 18, 2025  
IGI Report No LG758521035  
**OVAL BRILLIANT**  
9.87 X 7.26 X 4.61 MM  
2.06 CARATS  
Color Grade **D**  
Clarity Grade **VS 1**  
Table **61%**  
Depth **14%**  
Girdle **Medium to Slightly Thick (Faceted)**  
Culet **Pointed**  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG758521035**  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa